

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Stephen St. Germain et al  
 FILED: Concurrently Herewith  
 FOR: METHOD FOR FORMING AN ENCAPSULATED  
 DEVICE AND STRUCTURE  
 Date: 6/25/2003

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DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.56

Honorable Assistant Commissioner for Patents  
 Washington, D.C. 20231

SIR:

It is respectfully requested that the prior art listed on FORM PTO-1449 be considered in the examination of the subject application and made of record therein. A copy of the listed prior art is enclosed herewith.

No representation is made or intended that the listed prior art enclosed herewith is material to patentability of the subject patent application.

No representation is made or intended that a search has been made or that no better prior art than that listed is available.

Respectfully submitted,  
 Stephen St. Germain et al



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<b>Form PTO-1449</b>  LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use Several Sheets if Necessary)	ATTY. DOCKET NO.	SERIAL NO.
	Ons00494	
	APPLICANT Stephen St. Germain et al	
	FILING DATE	GROUP
	CONCURRENTLY	

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document #	Date	Country	Class/subclass	Translation Yes - No
	AM					
	AN					
	AO					
	AP					
	AQ					
	AR					

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AS	US Patent Application Publication Number US2002/0027267A1 "THIN-TYPE SEMICONDUCTOR DEVICE AND DIE PAD THEREOF", Lin et al, March 7, 2002.
	AT	US Patent Application Publication Number US2002/0180018A1 "LEADFRAME LOCKING STRUCTURES AND METHOD THEREFOR", Shermer, Dec. 5, 2002.
	AU	
	AV	
	AW	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.